

Notice of Allowability	Application No.	Applicant(s)	
	10/620,666	HESS ET AL.	
	Examiner	Art Unit	
	Shamim Ahmed	1765	
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	dication. If not include will be mailed in due	ed course. <b>THIS</b>
1. This communication is responsive to 7/12/05.			
2. ☑ The allowed claim(s) is/are <u>39-45</u> .			
3.	been received.  been received in Application No cuments have been received in this application.  between received.  control this communication to file a reply of the reply of this application.  between received.  control this received in Application to file a reply of this application.  between received.  control this received in Application No control this received in this received i	national stage applicational stage applicational stage application of the front (not the fi).	quirements OTICE OF
Attachment(s)  1. ☐ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date  4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. ☐ Notice of Informal Pa 6. ☑ Interview Summary Paper No./Mail Dat 7. ☑ Examiner's Amendm 8. ☑ Examiner's Stateme 9. ☐ Other	(PTO-413), e <u>9/27/05</u> nent/Comment  nt of Reasons for Allo Shamim Ahmed	ŕ
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## **EXAMINER'S AMENDMENT**

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Tod. A. Myrum on 9/27/05.

The application has been amended as follows:

IN THE SPECIFICATION:

At page 1, paragraph 0001, line 2, after the phrase "October 16, 2001," insert "abandoned,"

IN THE CLAIMS:

Cancel the non-elected claims 1-18 and also cancel claims 35-38.

Claim 39 is amended as follows:

39. (Currently amended) A method of-manufacturing a print head forming a cavitation layer of a print head comprising:

forming a first dielectric layer overlying at least a first portion of a substrate using atomic layer deposition;

forming a second dielectric layer having a first portion overlying at least a second portion of the substrate and a second portion, different from the first portion, overlying at least a portion of the first dielectric layer;

forming a cavitation layer overlying the first dielectric layer and in lateral contact with the first portion of the second dielectric layer using atomic layer deposition; and

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forming a third dielectric layer only on the second portion of the second dielectric layer using atomic layer deposition, and not on the cavitation layer.

- 2. The following is an examiner's statement of reasons for allowance: The prior art does not teach a process of forming a cavitation layer of a print head including the steps of forming a cavitation layer overlying the first dielectric layer and in lateral contact with the first portion of the second dielectric layer using atomic layer deposition and then forming a third dielectric layer only on the second portion of the second dielectric layer as the context of claim 39.
- 3. The closest prior art Hawkins (4,532,530) teaches a method of fabrication a printing head or fluid ejecting device, wherein a tantalum layer (46) is deposited as a protection layer, which resembles the claimed cavitation layer (col.5, lines 34-37 and figure 4A) but fails to teach forming a cavitation layer, which is in lateral contact with the first portion of the second dielectric layer and then forming a third dielectric layer only on the second portion of the second dielectric layer as the context of claim 39.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Shamim Ahmed whose telephone number is (571) 272-1457. The examiner can normally be reached on M-Thu (7:00-5:30) Every Friday Off.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine G. Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Shamim Ahmed Primary Examiner Art Unit 1765

SA September 27, 2005